

APR 18 2006

S/N 10/804,610

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: KITAOKA, et al. Examiner: T. Ho  
Serial No.: 10/804,610 Group Art Unit: 2818  
Filed: March 18, 2004 Docket: 10873.1420US01  
Title: METHOD OF MANUFACTURING GROUP III NITRIDE  
SUBSTRATE AND SEMICONDUCTOR DEVICE

CERTIFICATE UNDER 37 CFR 1.6(d): I hereby certify that this paper is being transmitted by facsimile to the  
U.S. Patent and Trademark Office on April 18, 2006.

By:   
Name: Peggy Kerkhove

REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that this application be accorded the benefits of  
Continued Examination in accordance with the provisions of 37 C.F.R. §1.114.

☒ A submission meeting of requirements of 37 C.F.R. 1.111 accompanies this  
paper; or

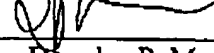
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Respectfully submitted,

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Dated: April 18, 2006

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